

Vacuum Drying oven VSD-e

Compact and flexible, safe and clean



With its double-walled, jointless interior, the VSD-e system cleans easily and is therefore ideal for GMP processes.

Technical data and features

Net shelf area: 0.18 m²

Shelf surface temperature: max. 200 °C

Heating: electric

Power: 230 V, 3 kW

Materials: high-grade stainless steels, Hastelloy, Inconel, Titanium

Surfaces: ground and polished

Door: tightly welded insulating jacket standard

Weight: 150 kg

PiNK's VSD-e is a compact, high-grade vacuum drying oven designed to provide users in industry, science, and research with a productive, safe, and clean lab system.

The advantages of the patented VSD with its GMP/FDA design are now available for smaller laboratory applications, too.

The VSD-e has an electric contact heater with integrated control. All it needs to start work is a socket and vacuum device.

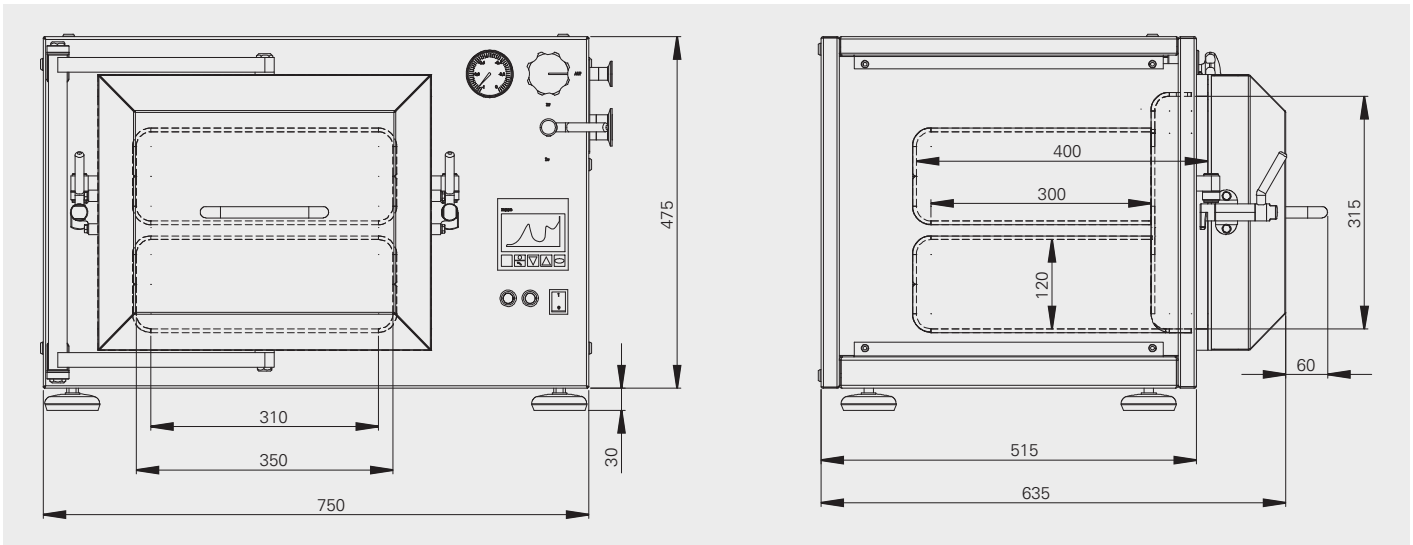
All VSD-e systems are of course leakage tested using helium and the rising-pressure method and the results documented in a test certificate.

System advantages

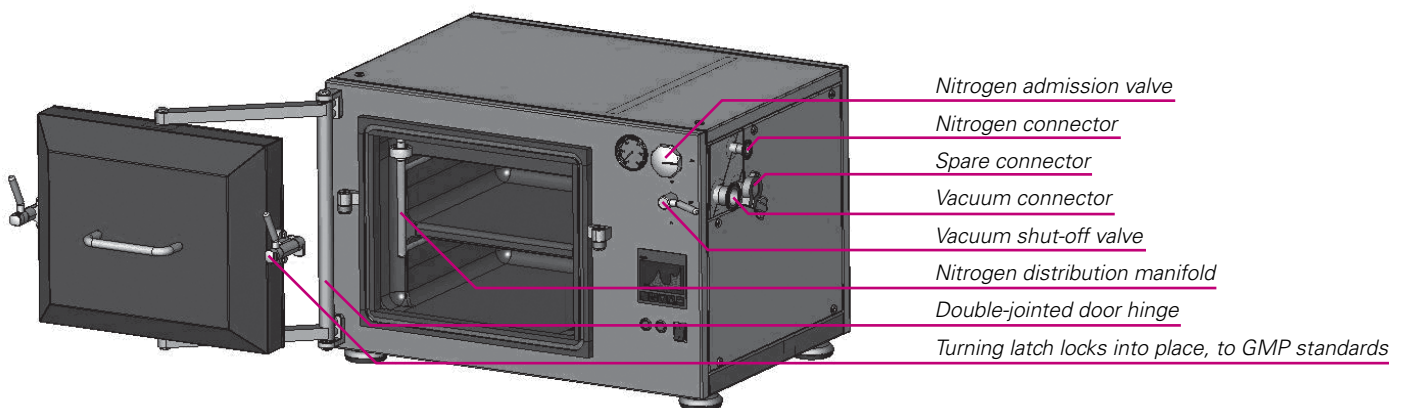
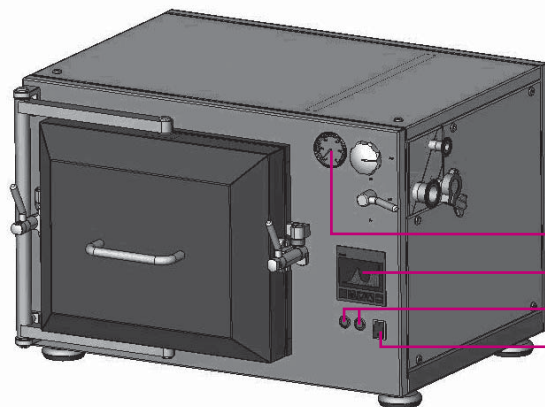
- Very compact
- Portable for flexibility
- No concealed surfaces
- Rounded corners, no edges
- No connecting leads for heating
- Outstanding surface quality (ground and polished)
- Double-jointed door hinge
- Easy to clean



Dimensions of the vacuum drying oven VSD-e



Features VSD-e



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